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Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Attention: Examiner Lan Vinh
Art Unit: 1765

June 24, 2004

Re: **ETCHING METHOD OF HARDLY-ETCHED MATERIAL AND SEMICONDUCTOR
FABRICATING METHOD AND APPARATUS USING THE METHOD**
U.S. Application No.: 10/090,761
Attorney Docket No.: 500.41317X00

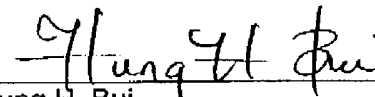
SUBMISSION OF DOCUMENTS

Sir:

Applicants hereby submit the attached "Amendment" (22 pages) in the above-identified application.

CERTIFICATE OF TRANSMISSION:

I hereby certify that the attached "Amendment" prepared in response to the Office Action (Paper No. 031804) dated on March 24, 2004, is being formally filed in the USPTO via Group 1765; Examiner Lan Vinh; Facsimile No. 703-872-9306 on **June 24, 2004**.


Hung H. Bui

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